

#26/Supr
IOS
4/17/03
MS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 09/602,395
Filing Date June 22, 2000
Inventor John T. Moore
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner T. Pham
Attorney Docket No. MI22-1384
Title: Methods of Forming Oxide Regions Over Semiconductor Substrates

Assistant Commissioner for Patents
Washington, D.C. 20231

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9318 on the date shown below:

1. Supplemental Information Disclosure Statement w/PTO-1449 and copy of cited reference

Dated: January 15, 2003

By: Jaime M. White
Jaime M. White
Telephone No. (509) 624-4276
Facsimile No. (509) 838-3424

NUMBER OF PAGES IN FACSIMILE: 12

FAX RECEIVED

JAN 15 2003

TECHNOLOGY CENTER 2800